



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 15, 2026	
IGI Report Number	LG837628922
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL POLYGON STEP CUT
Measurements	9.89 X 6.49 X 3.77 MM

GRADING RESULTS

Carat Weight	2.03 CARATS
Color Grade	F
Clarity Grade	VS 1

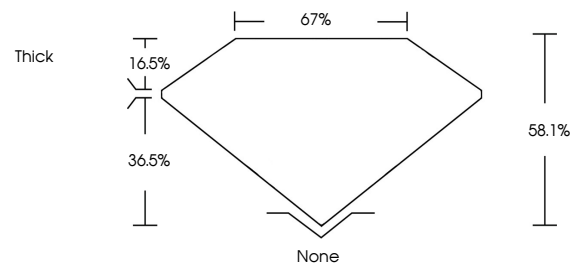
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG837628922

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

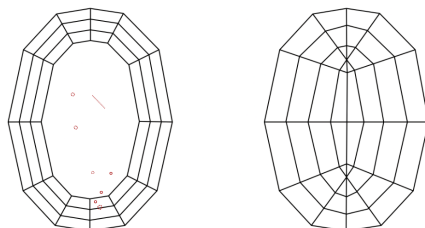
LG837628922
Report verification at igi.org

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

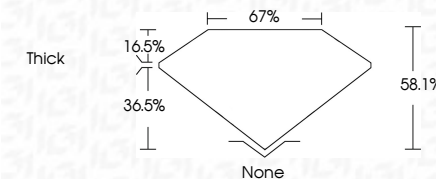
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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September 15, 2026
 IGI Report No LG837628922
 OVAL POLYGON STEP CUT

Carat Weight	2.08 CARATS
Color Grade	F
Clarity Grade	VS 1
Depth	88.1%
Table	67%
Girdle	Thick
Culet	None
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE

Comments:
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www.igi.org